

ABSTRACT

A laser unit is arranged in an area of a floor surface, the width of which area is defined by maintenance areas, on both sides of an exposure-apparatus main body, inclusive. Furthermore, the exposure-apparatus main body and the laser unit are arranged on the floor surface such that maintenance areas of the both overlap each other at least partially. Moreover, a C/D is connected in-line with the front surface of the exposure-apparatus main body, and in the side of the exposure-apparatus main body, which side is in front of the optical axis of the projection optical system and which is connected with the C/D, a housing is provided which has a delivery port into and from which a mask container is loaded and unloaded by a ceiling-transport system that moves along a rail. Therefore, the laser unit is not further out into the maintenance areas than both side surfaces of the exposure-apparatus main body; the necessary area of the floor can be reduced, and the structure of a mask-transport system inside the exposure-apparatus main body can be prevented from becoming complicated.